

Notice of References Cited	Application/Control No. 10/657,669	Applicant(s)/Patent Under Reexamination HWANG ET AL.	
	Examiner Benjamin Su	Art Unit 2616	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0128742	07-2003	Johnson, David	375/147
*	B	US-2004/0001528	01-2004	Kim et al.	375/130
*	C	US-7,003,019	02-2006	Zeira, Ariela	375/147
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
	O					
	P					
	Q					
	R					
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	T					

NON-PATENT DOCUMENTS

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	V	
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